a first conveyance path extending horizontally for coupling the first port to the second port;

a coating module arranged along one side of the first conveyance path extending horizontally; and

a first carrier, which moves between the first port and the second port via the first conveyance path, for carrying a substrate to the first port or the second port of the coating module.

(Once amended) The apparatus of Claim 1, wherein the developing means includes: 2. a second conveyance path extending horizontally for coupling the first port to the second port;

a developing module which is arranged along one side of the second conveyance path; and

a second carrier, which moves between the first port and the second port via the second conveyance path, for carrying the substrate to the first port or the second port or the developing module.

The apparatus of Claim 1, wherein the second port is coupled to an exposure system.

The apparatus of Claim 1, wherein the coating means and the developing means are isolated from each other by an intermediate wall.

(Once amended) The apparatus of Claim 1, wherein the coating module includes: a coater which is arranged at one side of the first conveyance path; and a bake unit which is arranged at the other side of the first conveyance path and opposite to the coater.

The apparatus of Claim 4 further comprising an air-conditioning apparatus, which is installed at the intermediate wall, for removing particles created in the coating means and the developing means.

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The apparatus of Claim 5, wherein the bake unit includes: at least one heating plate for heating up a substrate; and at least one cooling plate for cooling down the heated substrate.

(New) The apparatus of Claim 5, wherein the developing module includes:

a developer which is arranged at one side of the second conveyance path; and
a bake unit which is arranged at the other side of the second conveyance path and
opposite to the developer.

(New) The apparatus of Claim 2, wherein the first conveyance path and the second conveyance path extend parallel with each other.

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